

ABSTRACT OF THE DISCLOSURE

A production process of a light emitting device capable of easily forming a fixed shape insulator layer irrespective of the quality of the material of a substrate is provided. The process of the present invention includes a process of forming an insulator layer by an electrophotography method, in the production process of a light emitting device equipped with a substrate, light emitting layers formed on the substrate, and an insulator layer mutually partitioning the light emitting layers.